

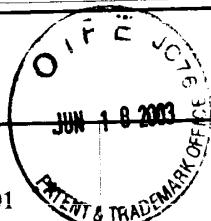
Petition For Revival Of An Application For Patent Abandoned Unintentionally
Under 37 CFR 1.137(b) (Large Entity)

#8
Docket No.
TI-32931

In Re Application Of: Jozef D. Mitros

Serial No.
10/020,034

Filing Date
December 7, 2001



Examiner
Long Pham

Group Art Unit
2814

Invention: METHOD FOR FABRICATING LOW chc DEGRADATION MOSFET TRANSISTORS

ASSISTANT COMMISSIONER FOR PATENTS

Attention: Office of Petitions
Box DAC
Washington, D.C. 20231

NOTE: If information or assistance is needed in completing this form, please contact Petitions Information at (703) 305-9282.

The above-identified application became abandoned for failure to file a timely and proper response to a notice or action by the Patent and Trademark Office. The date of abandonment is the day after the expiration date of the period set for reply in the Office notice or action plus any extension of time actually obtained.

APPLICANT HEREBY PETITIONS FOR REVIVAL OF THIS APPLICATION

NOTE: A grantable petition requires the following items:

- (1) Petition fee;
- (2) Reply and/or issue fee;
- (3) Terminal disclaimer with disclaimer fee--required for all utility and plant applications filed before June 8, 1995; and for all design applications; and
- (4) Statement that the entire delay was unintentional.

1. A proposed reply to the above-identified notice or action:

The proposed reply is in the form of: Amendment and RCE

2. The issue fee:

is enclosed. was paid on

3. The abandoned application was a:

design application. utility application. plant application.

SEARCHED BY [Signature]

4. A terminal disclaimer (and fee) disclaiming a period equivalent to the period of abandonment is enclosed.

5. Since this utility/plant application was filed on or after June 8, 1995, no terminal disclaimer is required.

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Calculation and Payment of Fees

Enclosed are the following fees:

6. <input checked="" type="checkbox"/> Petition fee under 37 CFR 1.17(m) in the amount of:	\$1,210.00
7. <input type="checkbox"/> Fee for amendment in the amount of:	
8. <input type="checkbox"/> Fee for extension of time to respond to Office Action in the amount of:	
9. <input type="checkbox"/> Issue fee in the amount of:	
10. <input type="checkbox"/> Continuing application filing fee in the amount of:	
11. <input type="checkbox"/> Terminal disclaimer fee in the amount of:	
12. <input type="checkbox"/>	

The fee of \$1,210 is to be paid as follows:

A check in the amount of the fee is enclosed.
 The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 20-0668
A duplicate copy of this sheet is enclosed.

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Statement

The entire delay in filing the required reply from the due date for the required reply until the filing of a grantable petition under 37 CFR 1.137(b) was unintentional.



Signature

Dated:

Jay M. Cantor
Reg. No. 19906
(202) 639-7713

RECEIVED

U.S. PATENT AND TRADEMARK OFFICE

CC:

I certify that this document and fee is being deposited on [redacted] with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence